

FIG. 1

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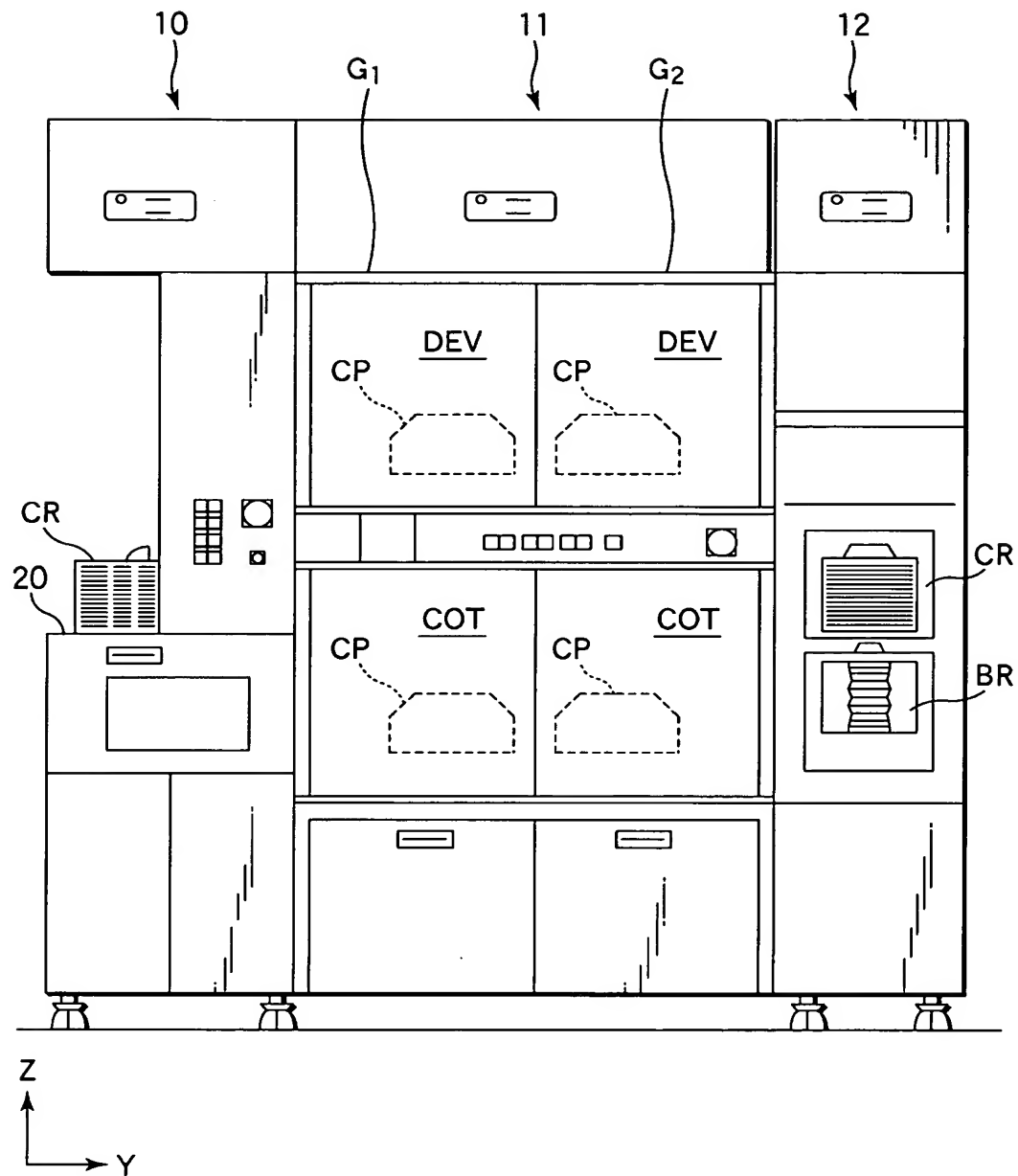


FIG. 2

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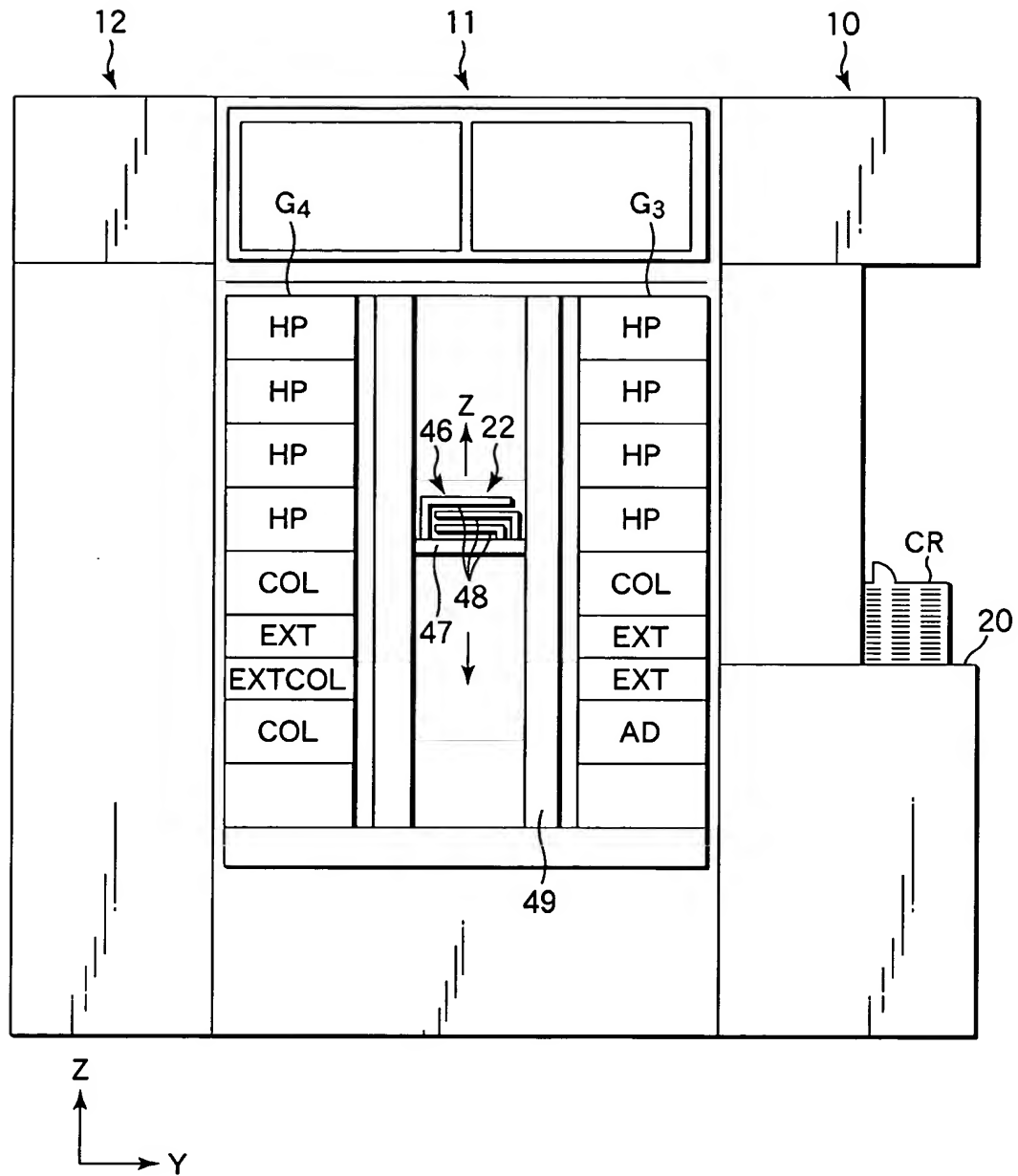


FIG.3

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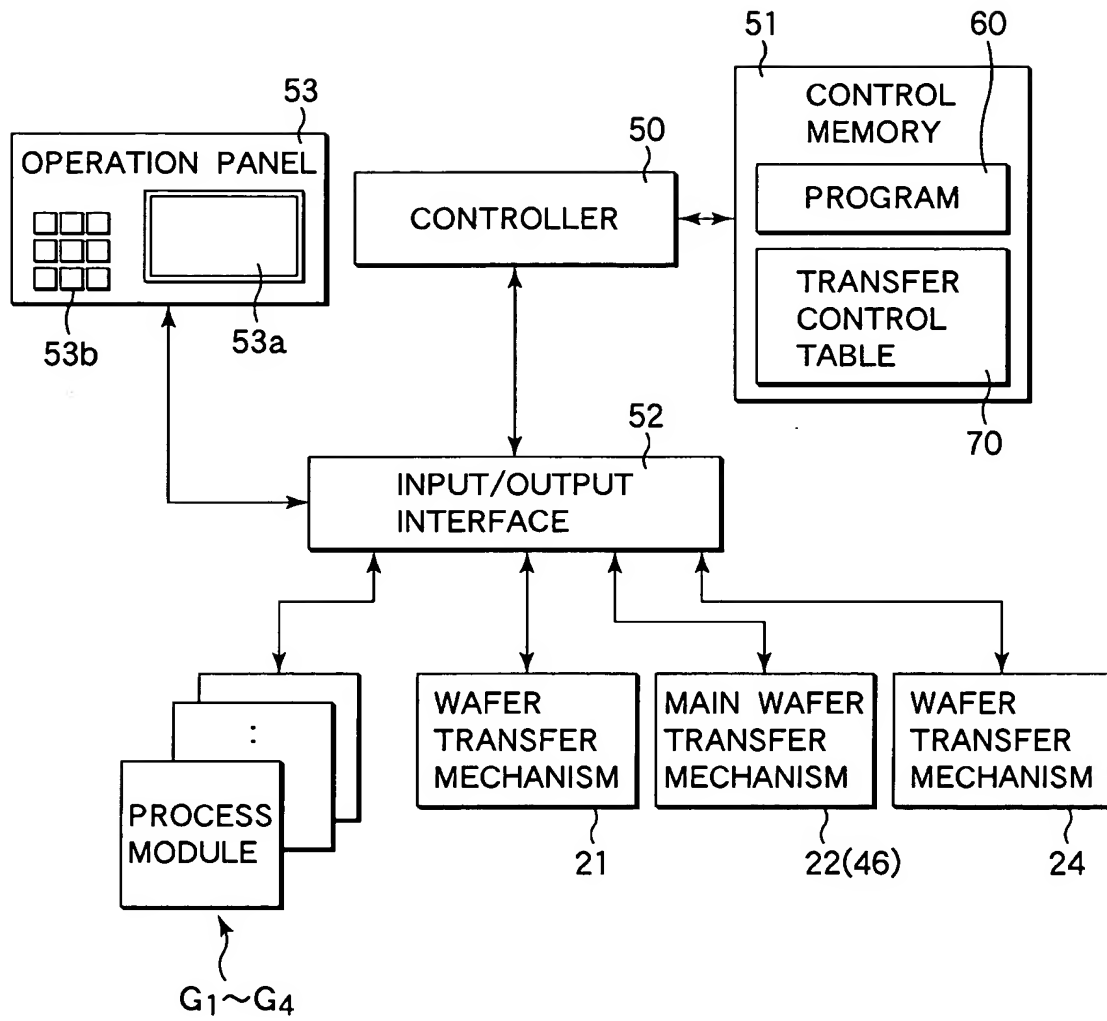
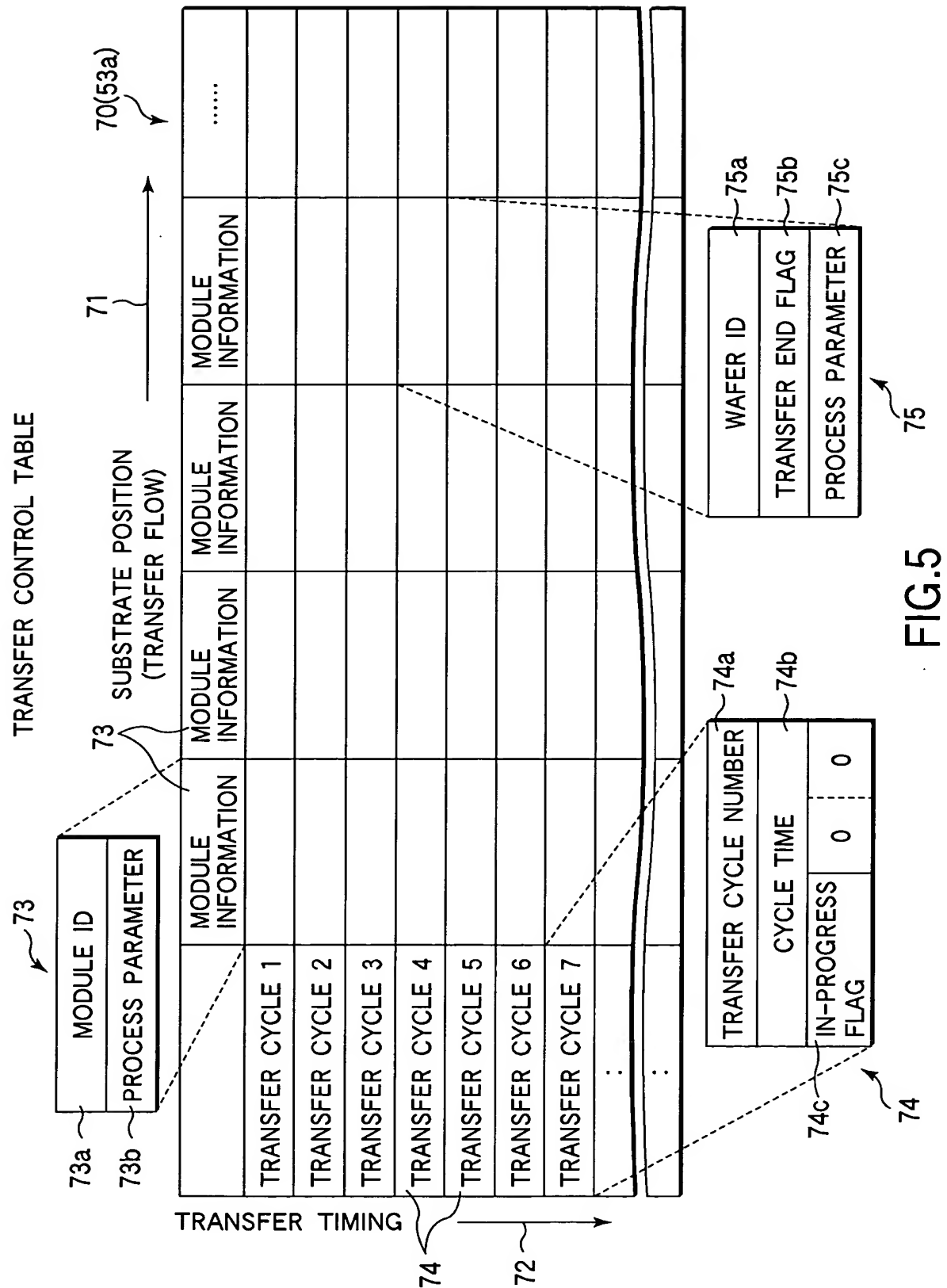


FIG.4



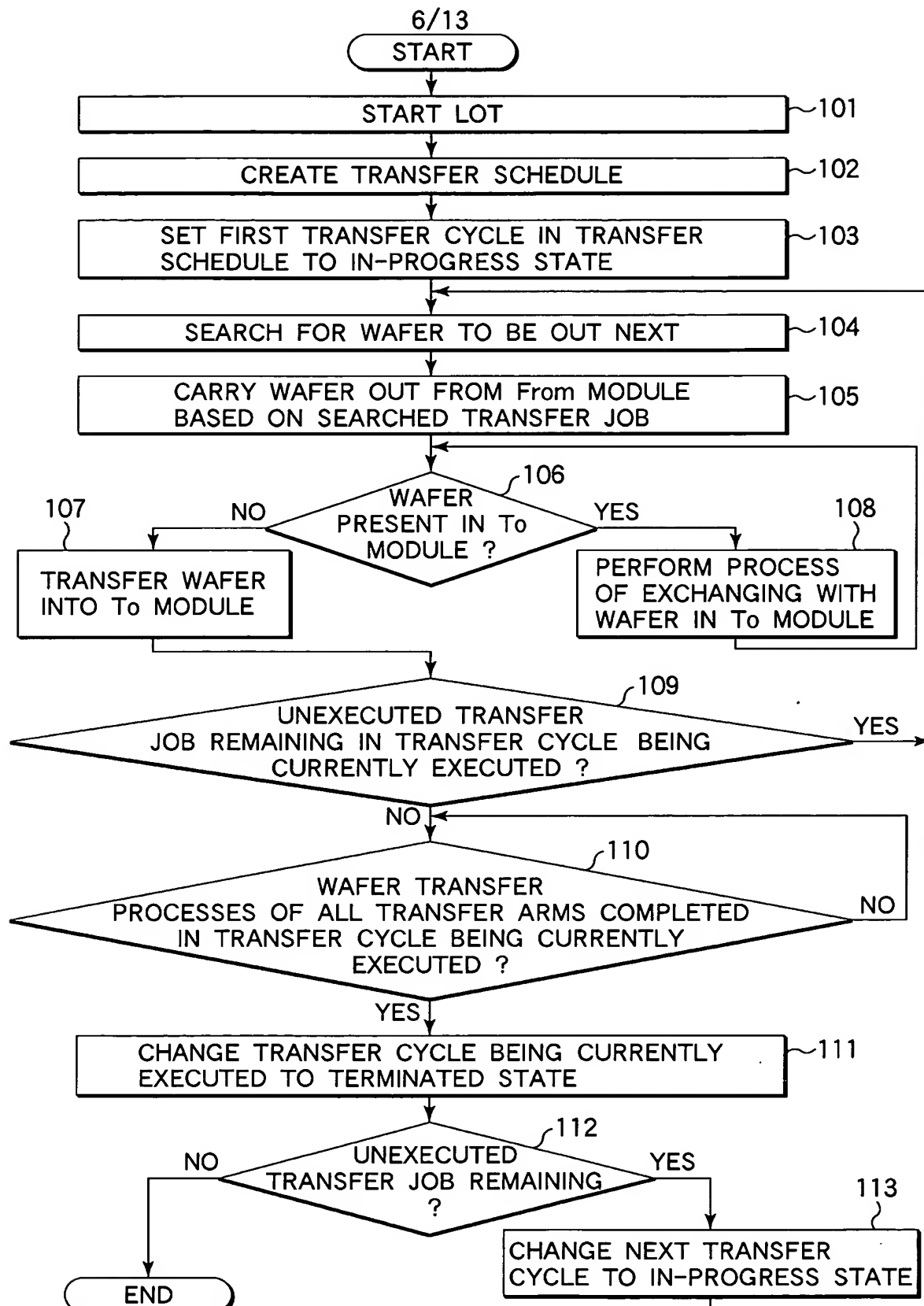


FIG.6

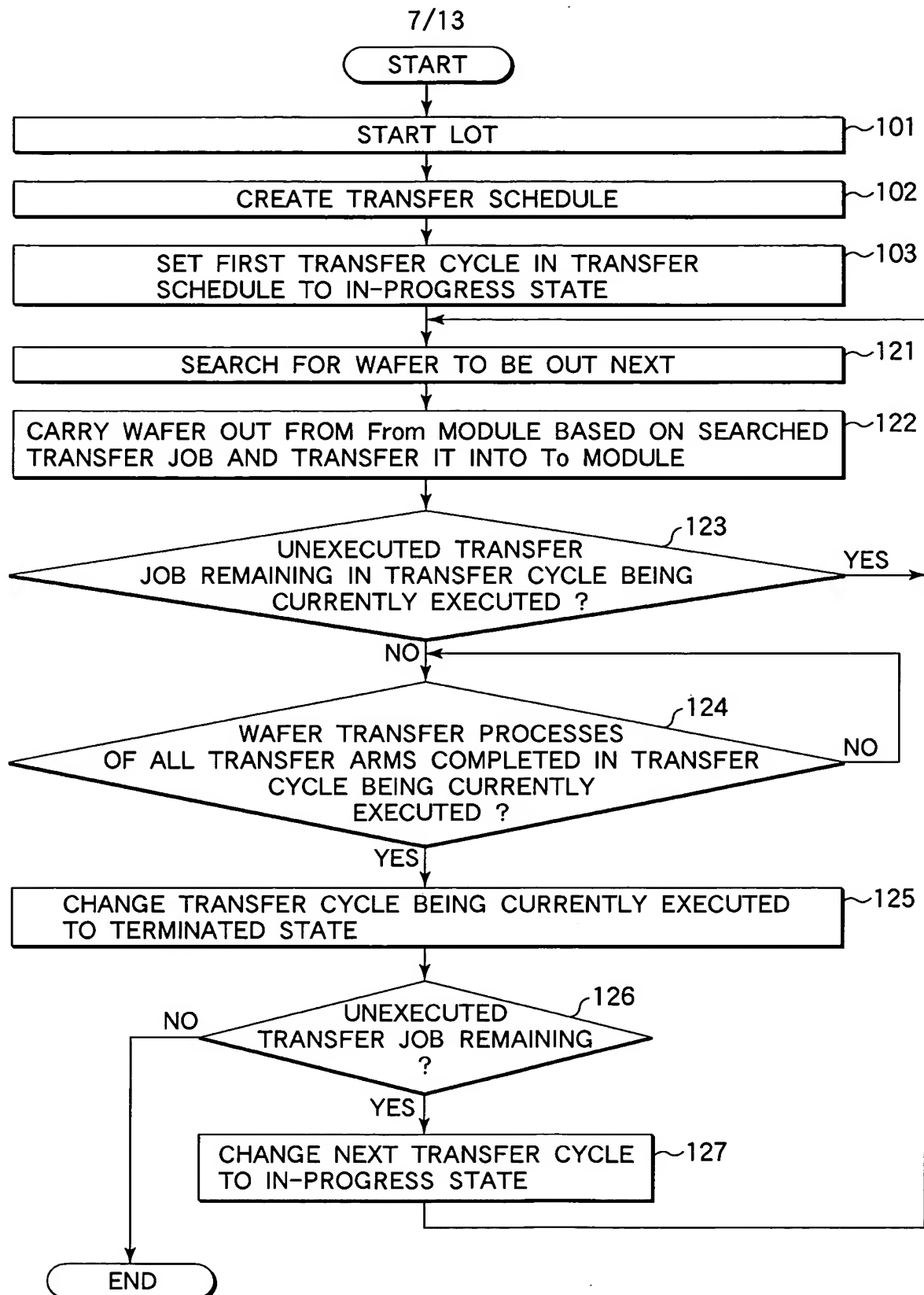


FIG.7

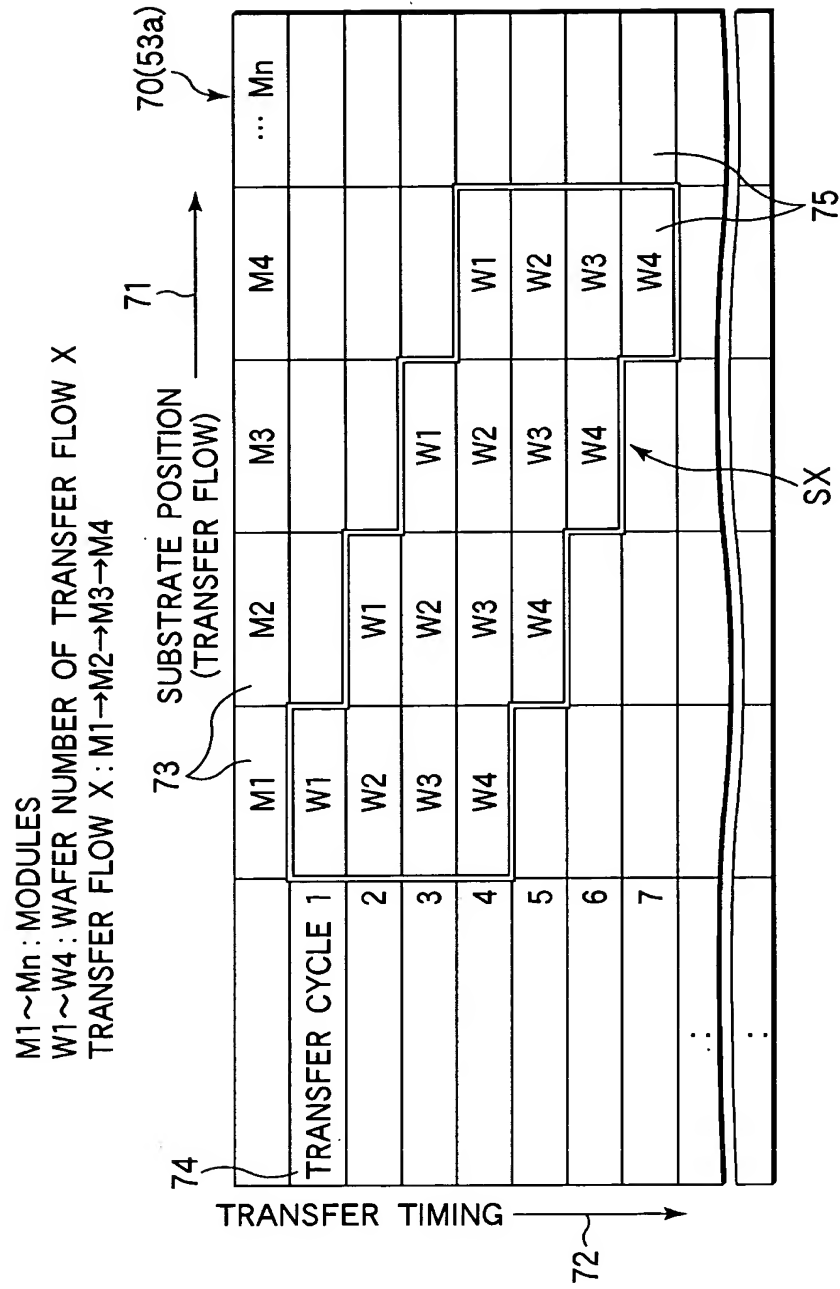


FIG.8

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M1~M6 : MODULES

A1~A5 : WAFER NUMBER OF LOT OF TRANSFER FLOW A

B1~B5 : WAFER NUMBER OF LOT OF TRANSFER FLOW B

TRANSFER FLOW A	M1→M2→M3→M4→M5→M6
TRANSFER FLOW B	M1→M2→M3→M5→M4→M6

FIG.9A

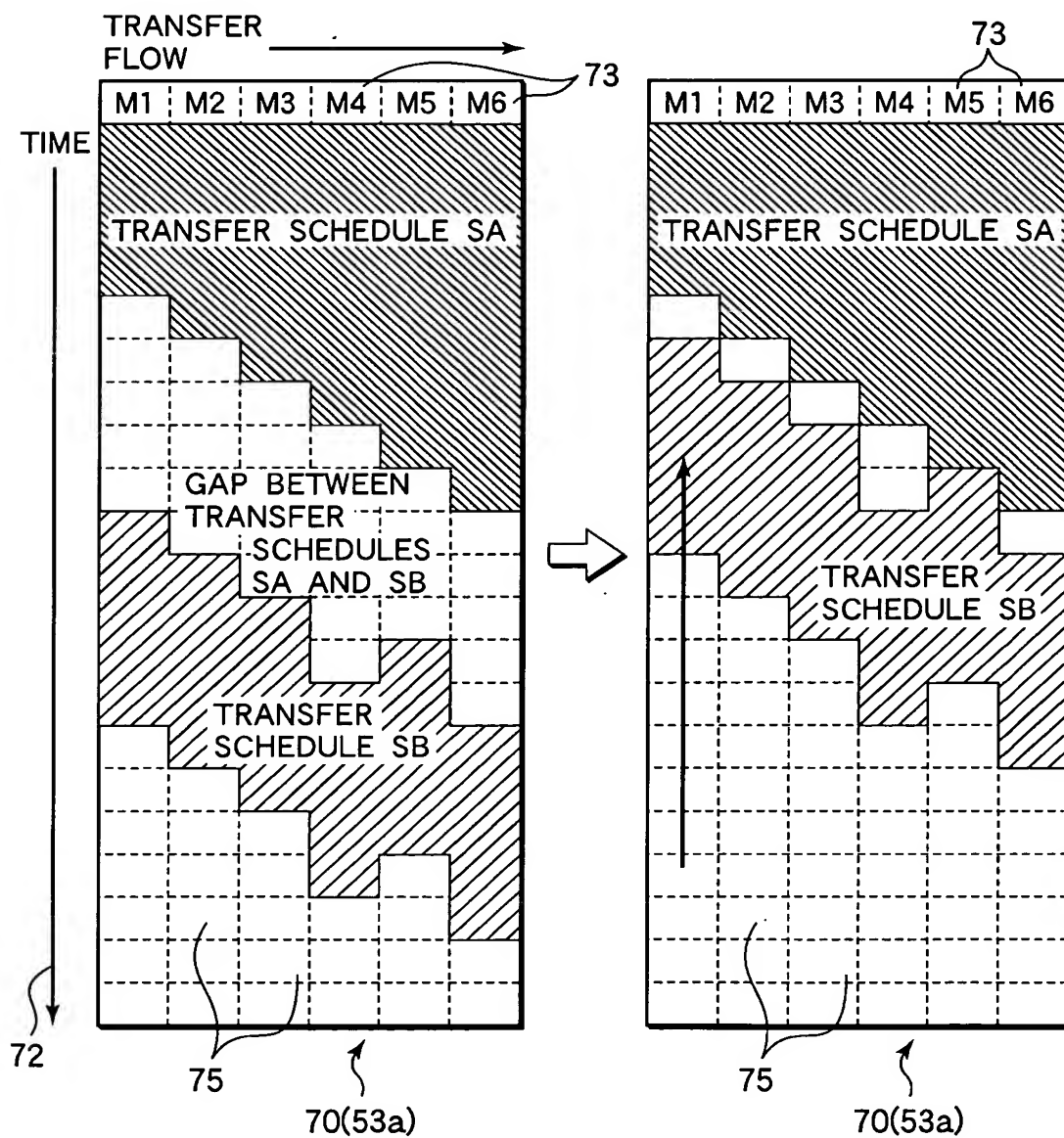


FIG.9B

FIG.9C

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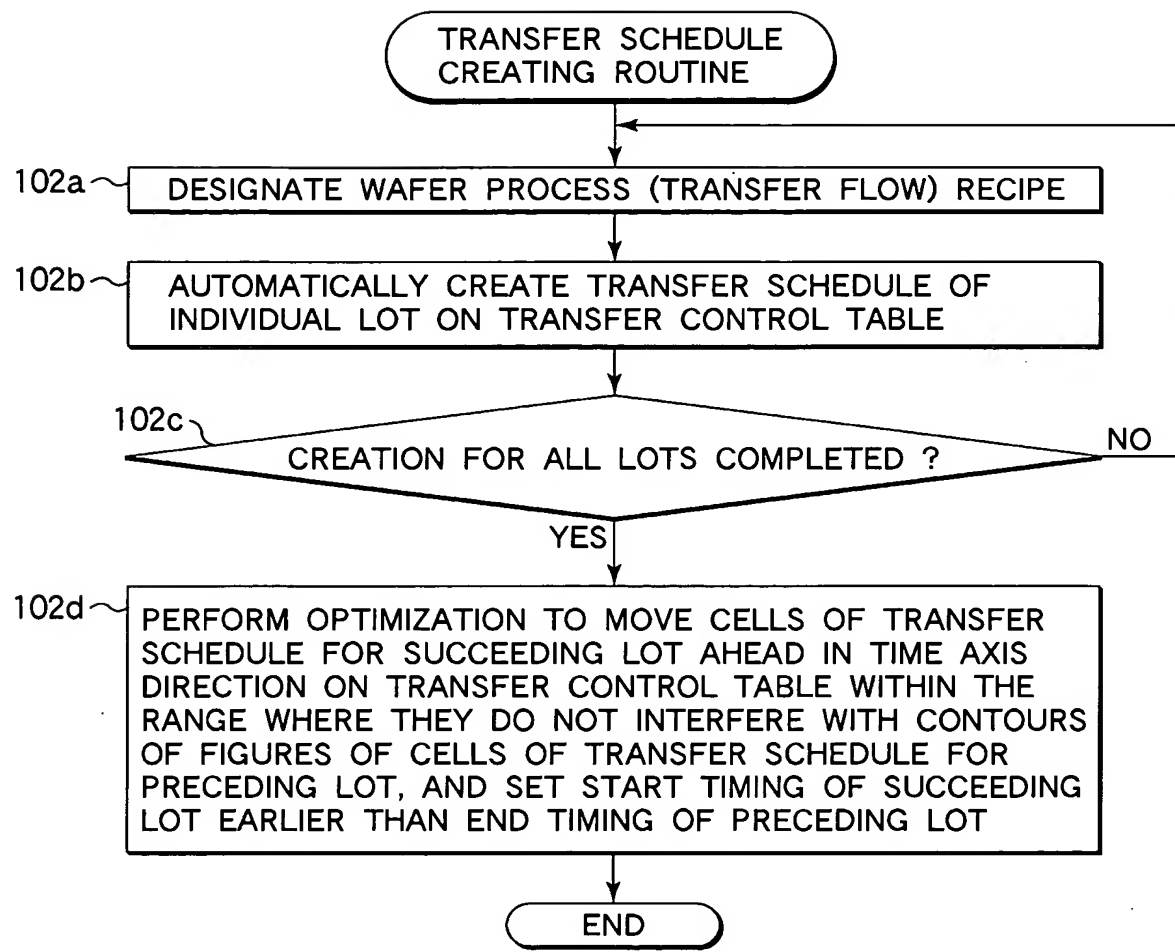


FIG.10

M1~M6 : MODULES
EIS : EXPOSURE APPARATUS INTERFACE STAGE
BUF : BUFFER PRECEDING EXPOSURE APPARATUS (IN BUFFER)
A1~A5 : WAFER NUMBER OF LOT OF TRANSFER FLOW A
B1~B5 : WAFER NUMBER OF LOT OF TRANSFER FLOW B

FIG.12A

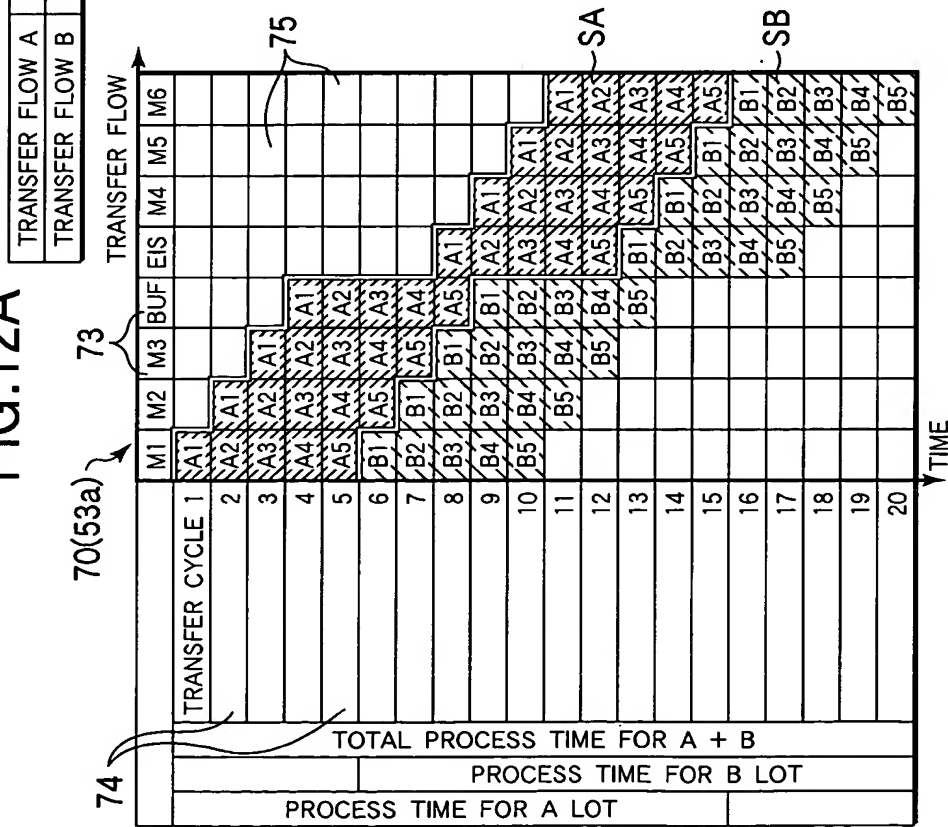


FIG.12B

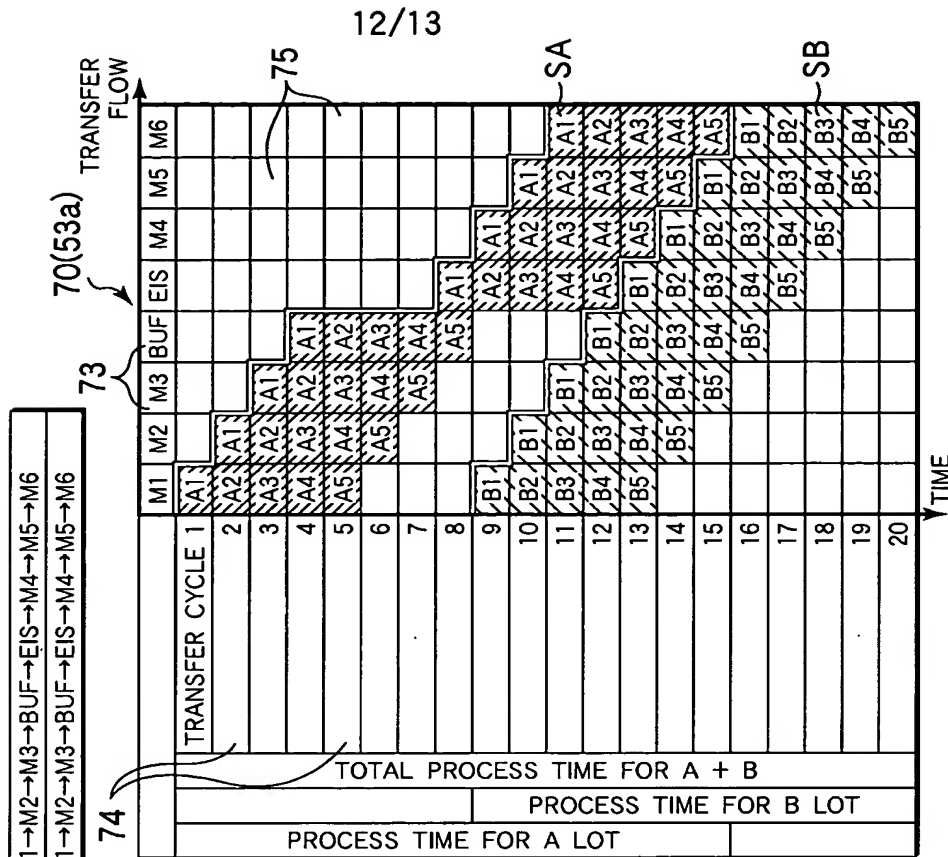


FIG.12C

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M1~M8 : MODULES

A1~A5 : WAFER NUMBER OF LOT OF TRANSFER FLOW A

B1~B5 : WAFER NUMBER OF LOT OF TRANSFER FLOW B

TRANSFER FLOW A	M1→M2→M3→M4→M6→M7→M8 M5
TRANSFER FLOW B	M1→M2→M3→M4→M5→M6→M7→M8

FIG.13A

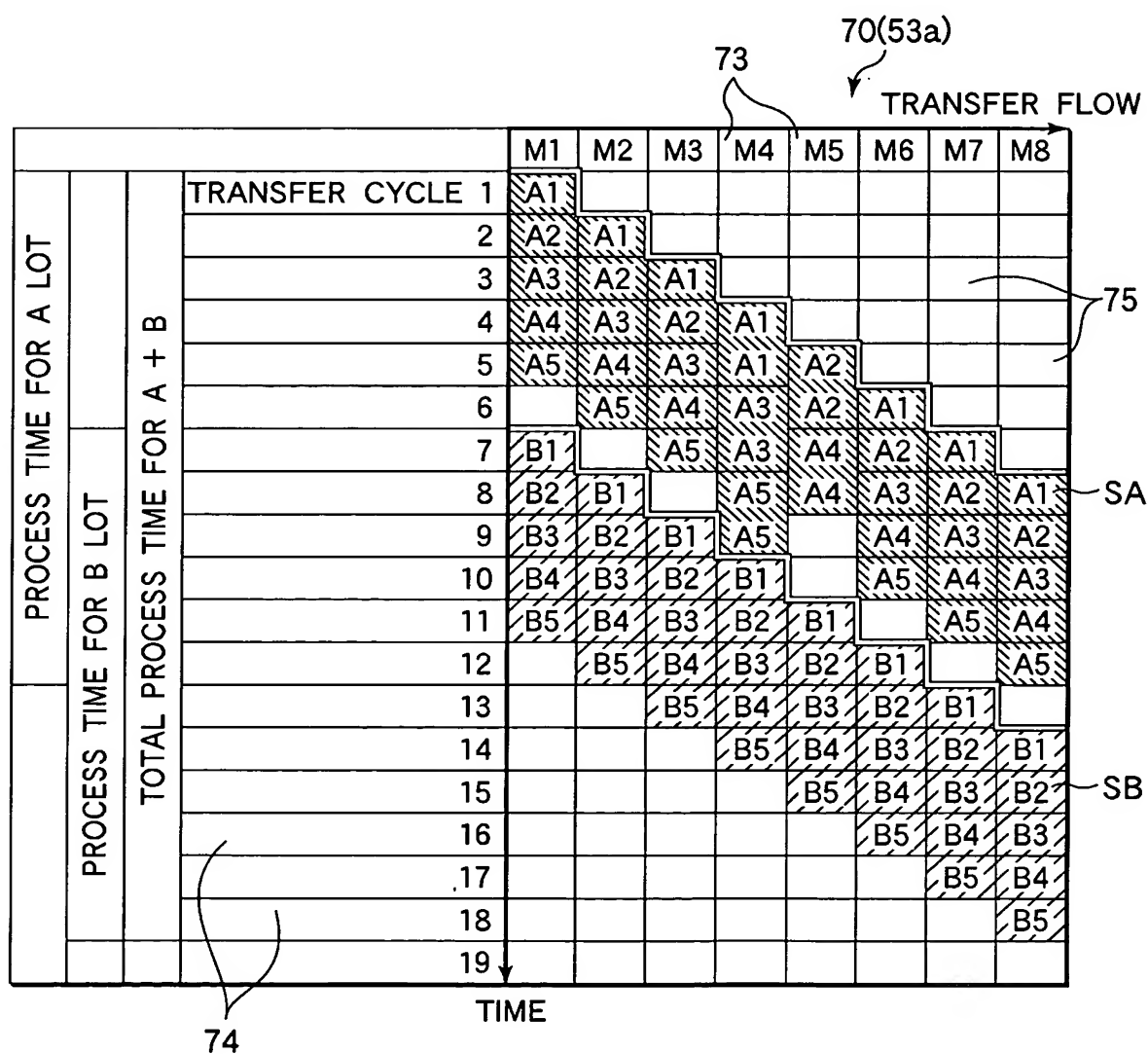


FIG.13B